



# UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
United States Patent and Trademark Office  
Address: COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, Virginia 22313-1450  
[www.uspto.gov](http://www.uspto.gov)



CONFIRMATION NO. 7541

Bib Data Sheet

SERIAL NUMBER 10/716,965	FILING DATE 11/19/2003 RULE	CLASS 438	GROUP ART UNIT 2813	ATTORNEY DOCKET NO. 36280
-----------------------------	-----------------------------------	--------------	------------------------	---------------------------------

## APPLICANTS

Kiyoshi Arita, Fukuoka, JAPAN;

\*\* CONTINUING DATA \*\*\*\*\* *None*

*TM*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2002-336415 11/20/2002  
JAPAN 2002-336416 11/20/2002

*TM*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 02/19/2004

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	JAPAN	DRAWING 11	CLAIMS 27	CLAIMS 3
Verified and Acknowledged	<i>Maur</i> <i>TM</i> Examiner's Signature Initials				

## ADDRESS

00116  
PEARNE & GORDON LLP  
1801 EAST 9TH STREET  
SUITE 1200  
CLEVELAND, OH  
44114-3108

## TITLE

Method of manufacturing semiconductor device, plasma processing apparatus and plasma processing method

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue )
RECEIVED 1276		